

# Readout system in japan

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# Purpose

NEWS is a directional search of WIMPs by nuclear emulsion

But it is much different from the past emulsion experiment

Detector (NIT)

:Need submicron track detection and high statics

**Readout system**

**:Need nanometric resolution and high scanning speed**

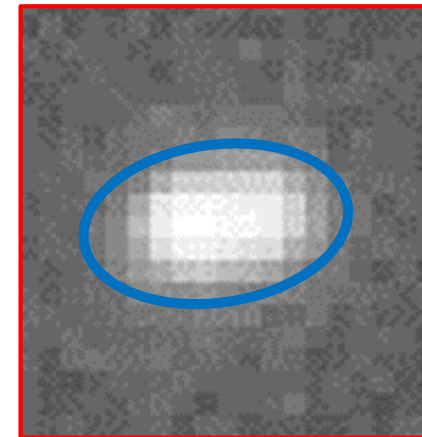
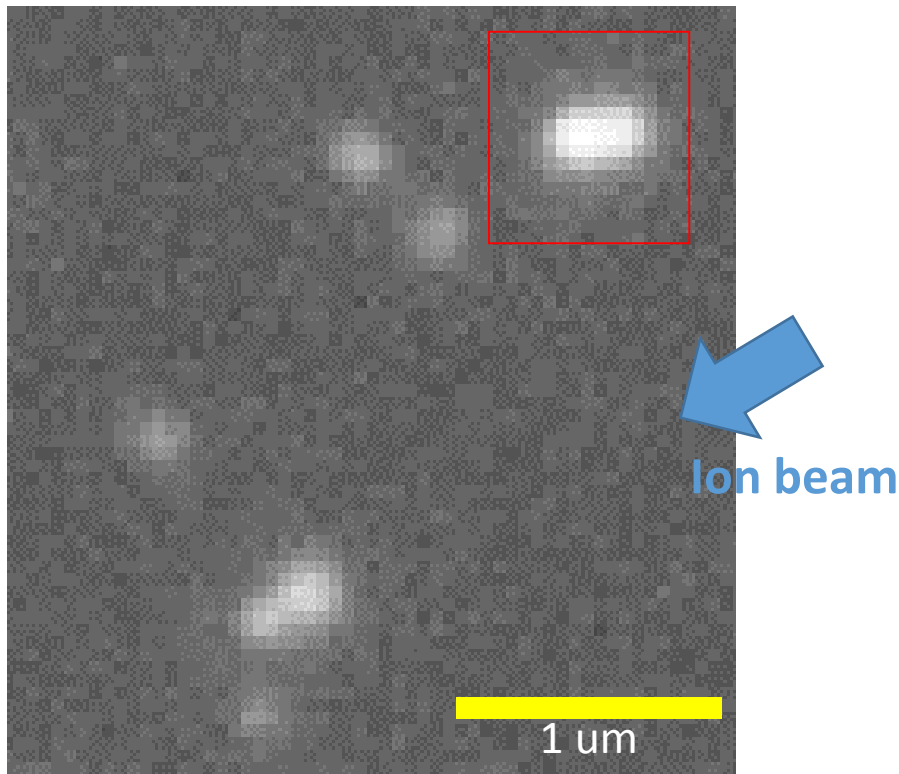


**share our scanning concept, strategy and future plan**

# Elliptical analysis

Our basic analysis is to get the shape of optical image

Optical image of Carbon track ( $E_k=60\text{keV}$ )

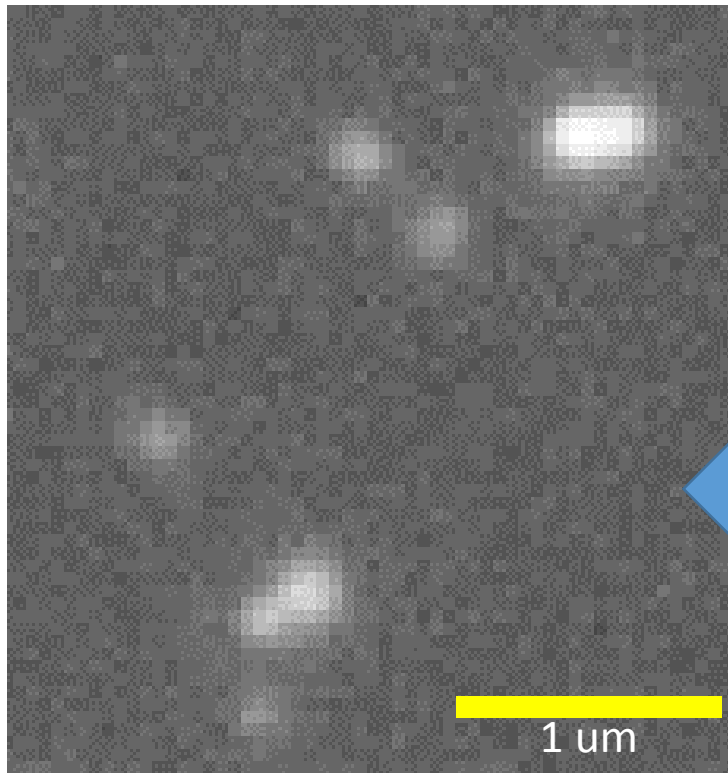


**Get direction and length of track**

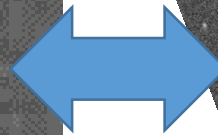
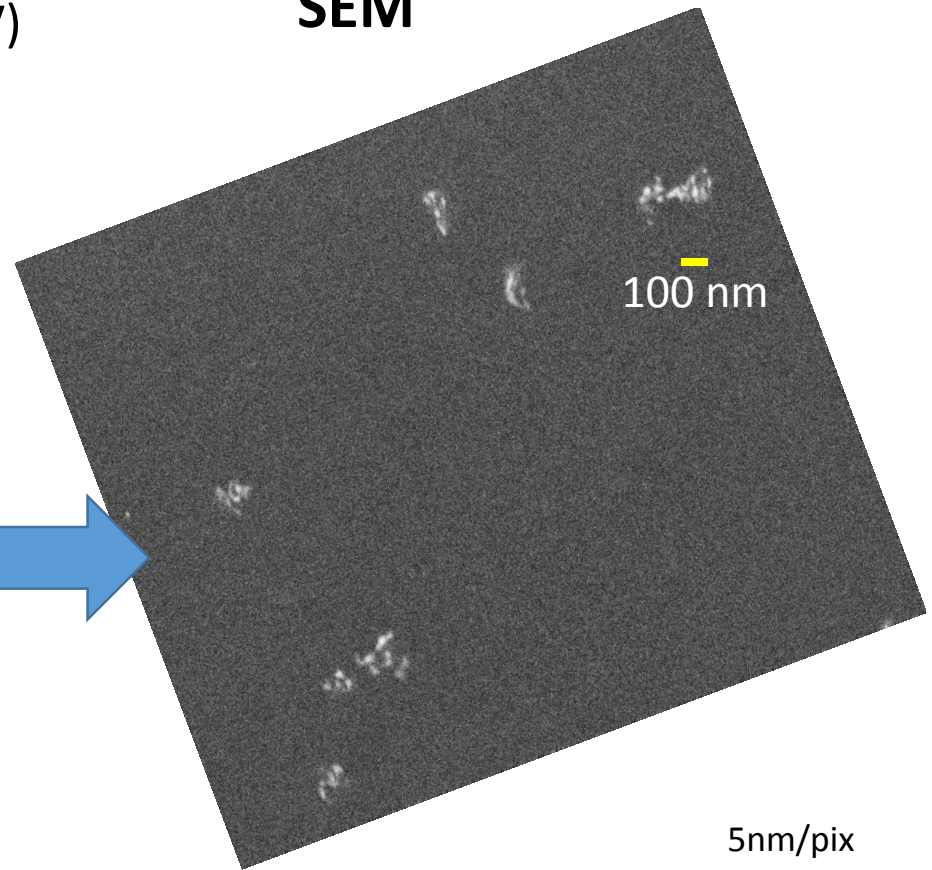
# Beyond the optical resolution

Want to get the information about inside of optical image

Optical image of Carbon ( $E_k=60\text{keV}$ )

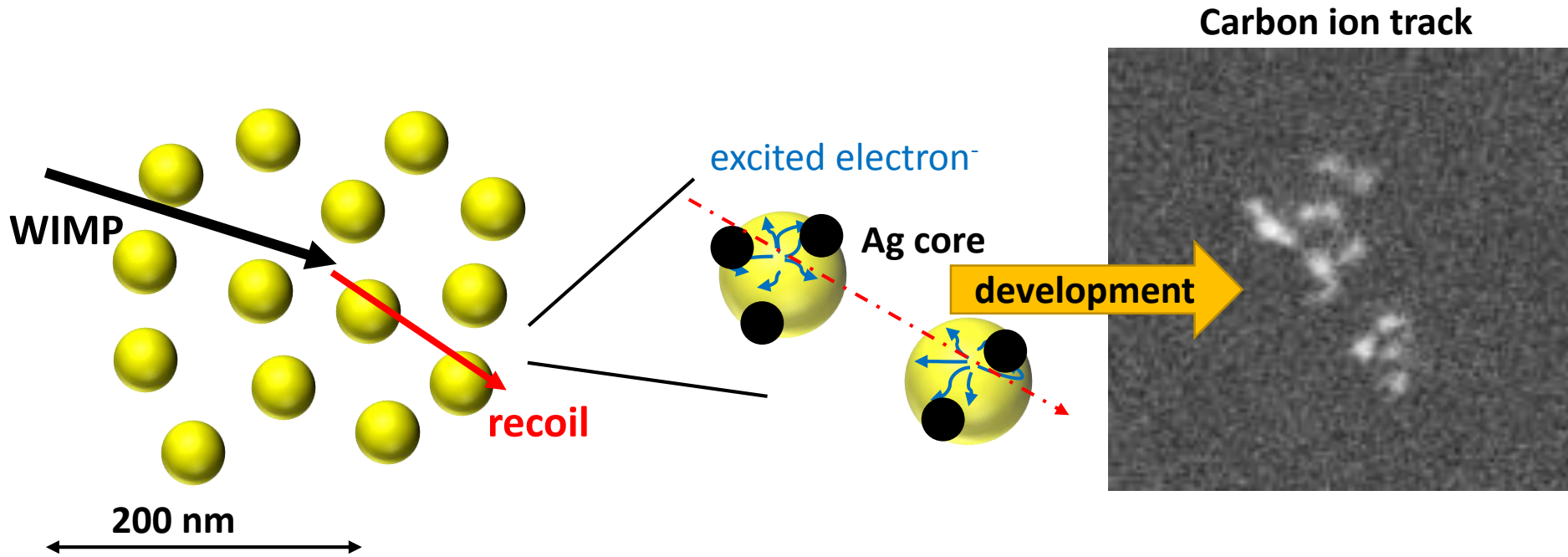


**SEM**



5nm/pix  
C 60keV

# Property of NIT



**This very complicated shape is much useful for noise discrimination**

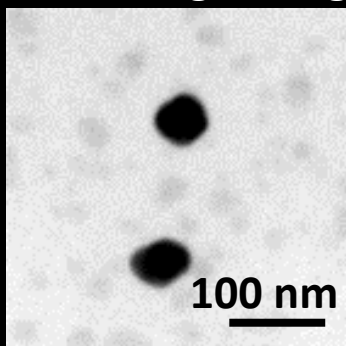
- The number of Ag core is decided by an energy loss of the particle  
→ e.g. electron does not make many Ag core
- this shape should be made only by the development process  
→ An impurity of NIT called “dust” should not be same shape

# Plasmon resonance effect

Localized Surface Plasmon Resonance is the optical response of nano Ag and Au

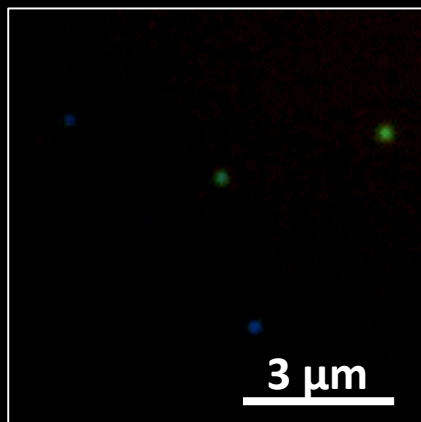
## Size effect

TEM image of Ag



diameter = 60nm

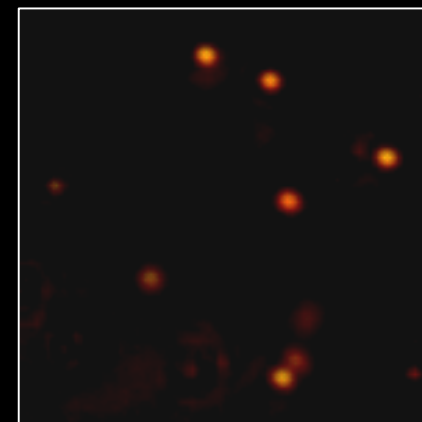
Optical image taken by color camera



diameter = 40nm

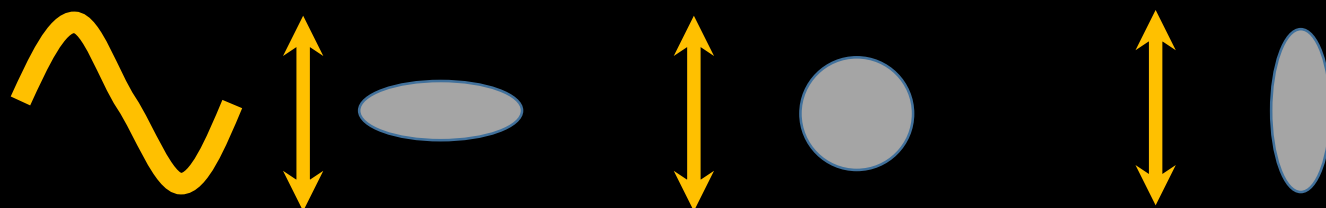


diameter = 60nm



diameter = 85nm

## Shape effect



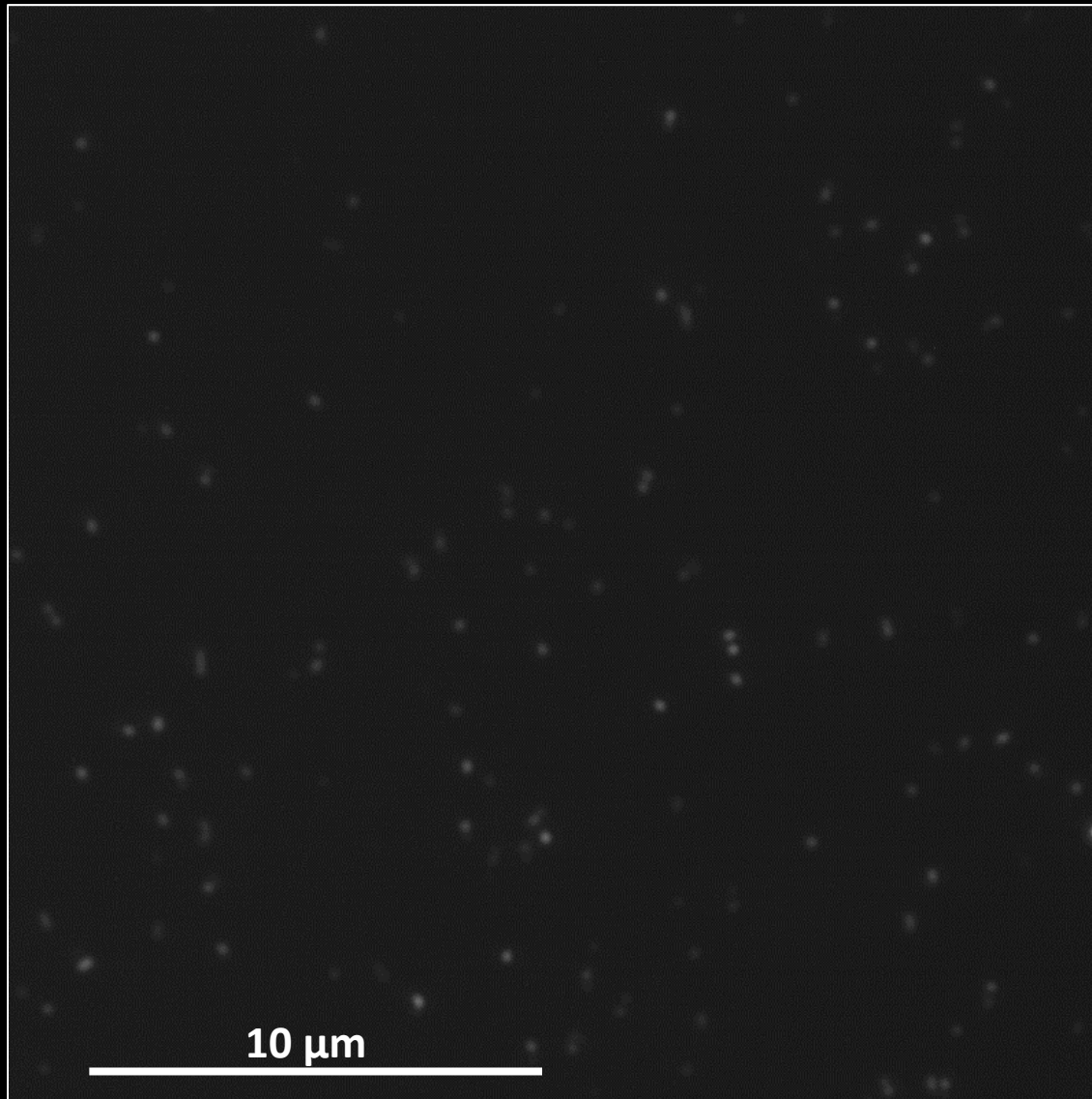
The direction of polarization

short

2016/11/2

long

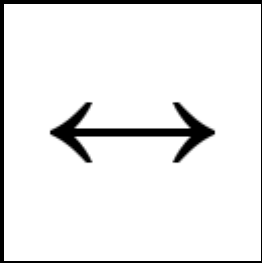
# Optical image of Carbon track (Ek100keV)



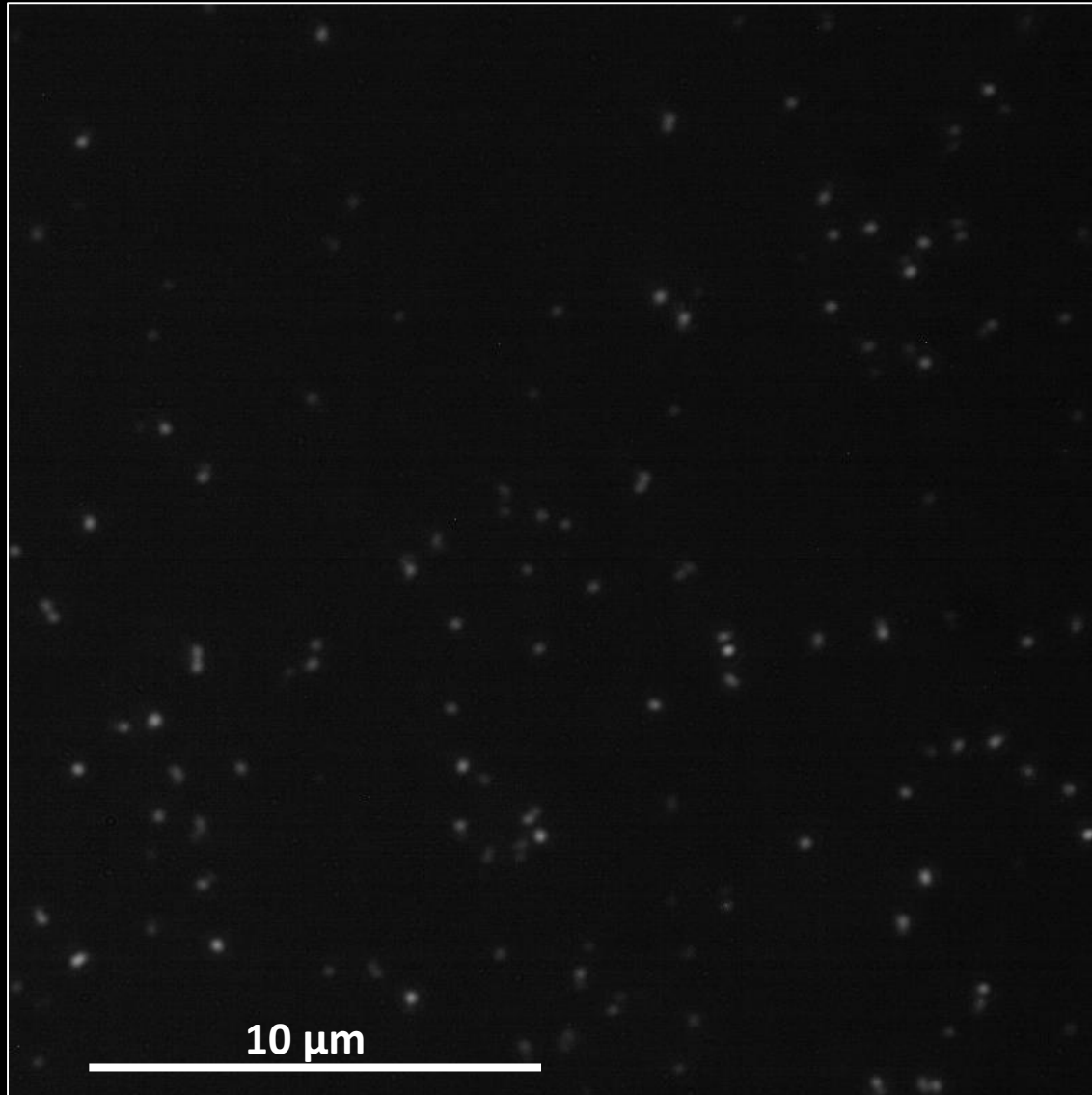
$\lambda = 450\text{nm}$

# Polarization effect

Polarizer angle



Taken at Napoli



$\lambda = 450\text{nm}$

10  $\mu\text{m}$



# Plasmon analysis by multi wavelength

450 nm

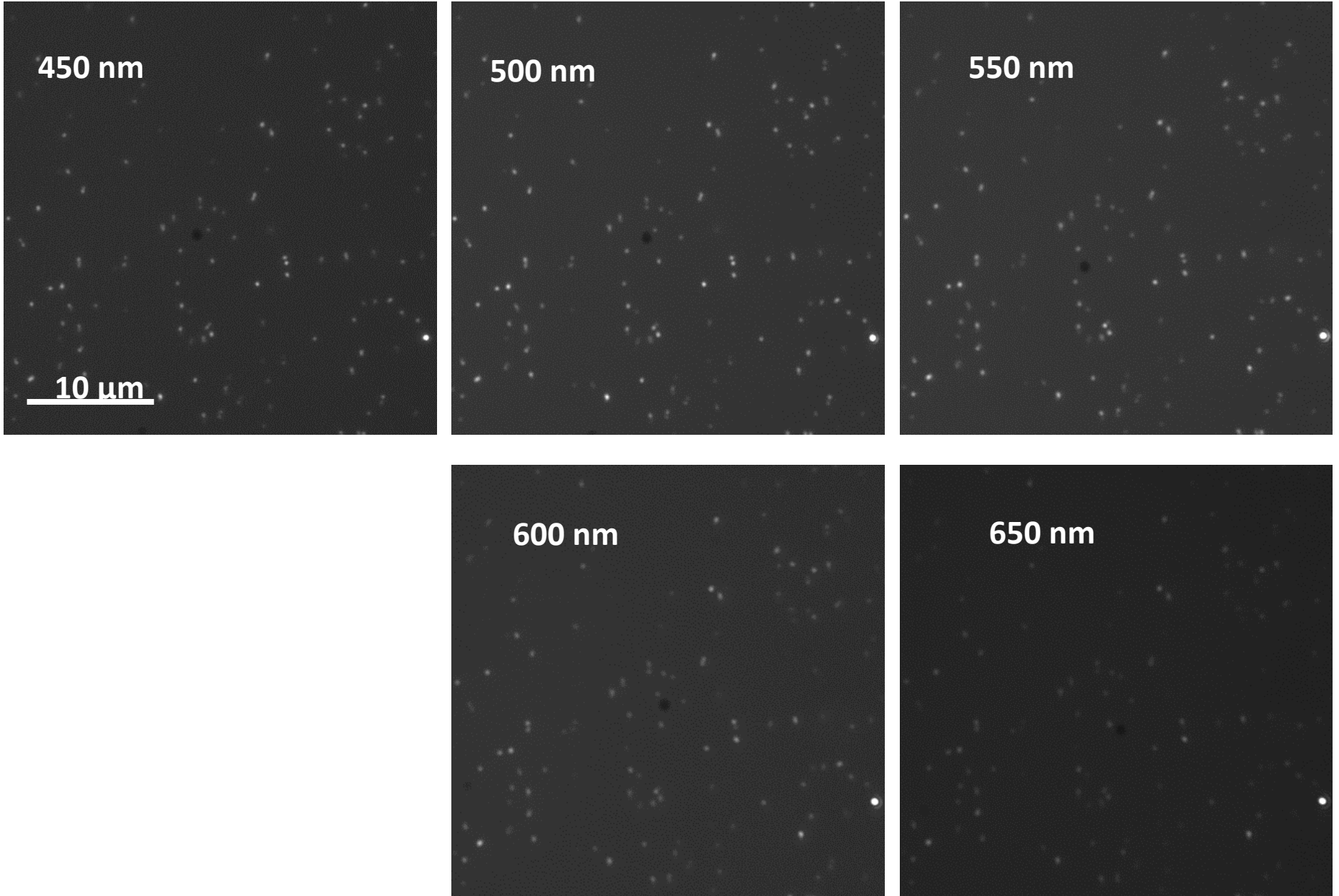
500 nm

550 nm

10  $\mu\text{m}$

600 nm

650 nm



# Scanning strategy

**1<sup>st</sup> selection** ~ elliptical analysis



Full volume scan

Select signal candidate

**2<sup>nd</sup> selection** ~ elliptical analysis again



1 % of Sphere image accidentally has high Ellipticity

Rescan 1<sup>st</sup> selection candidates

**3<sup>rd</sup> selection** ~ super resolution analysis

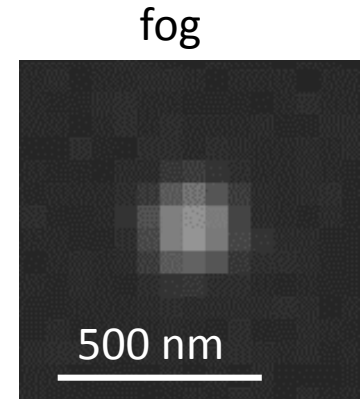
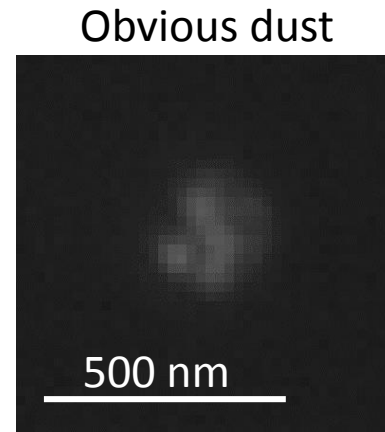
Use a nanometric information beyond the optical image by plasmon and neural network

Decide signal

# Scanning strategy

1<sup>st</sup> selection ~ elliptical analysis

Full volume scan



Reject by shape analysis

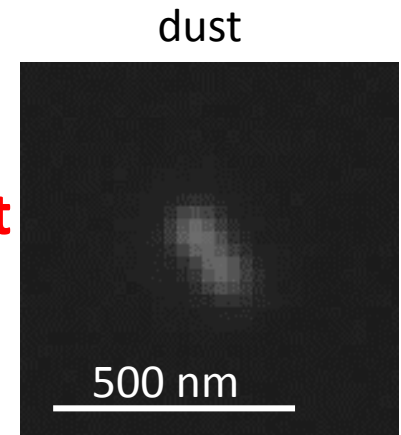
2<sup>nd</sup> selection ~ elliptical analysis again

Rescan 1<sup>st</sup> selection candidates

3<sup>rd</sup> selection ~ super resolution analysis

Reject by plasmon effect

Decide signal



# Japanese readout system for NEWS



## □ Set up

- High N.A Objective lens: N.A = 1.45 (x100)
- 4M pixel Camera, 180 fps  
View:  $(112.6 \mu\text{m})^2/\text{view}$   
55 nm/pix (measured)
- Xenon-Mercury lump
- High-path filter:  $\lambda < 500 \text{ nm}$
- Spatial resolution:  $\delta x = 233 \text{ nm}$  (measured)

- Stage is moved by stop and go

**current speed of 1<sup>st</sup> scanning ~ 1 g/ 10 days**

# Plan for upgrade of 1<sup>st</sup> scanning

First goal of Scanning speed

1 g /10 days  $\Rightarrow$  3 g/10 days

- stage speed

move X and Y stage with very low speed to reject the vibration now

$\Rightarrow$  will tune the best condition

- position accuracy of Z direction

Sometime miss the surface

$\Rightarrow$  use a piezo for smooth moving and better position resolution

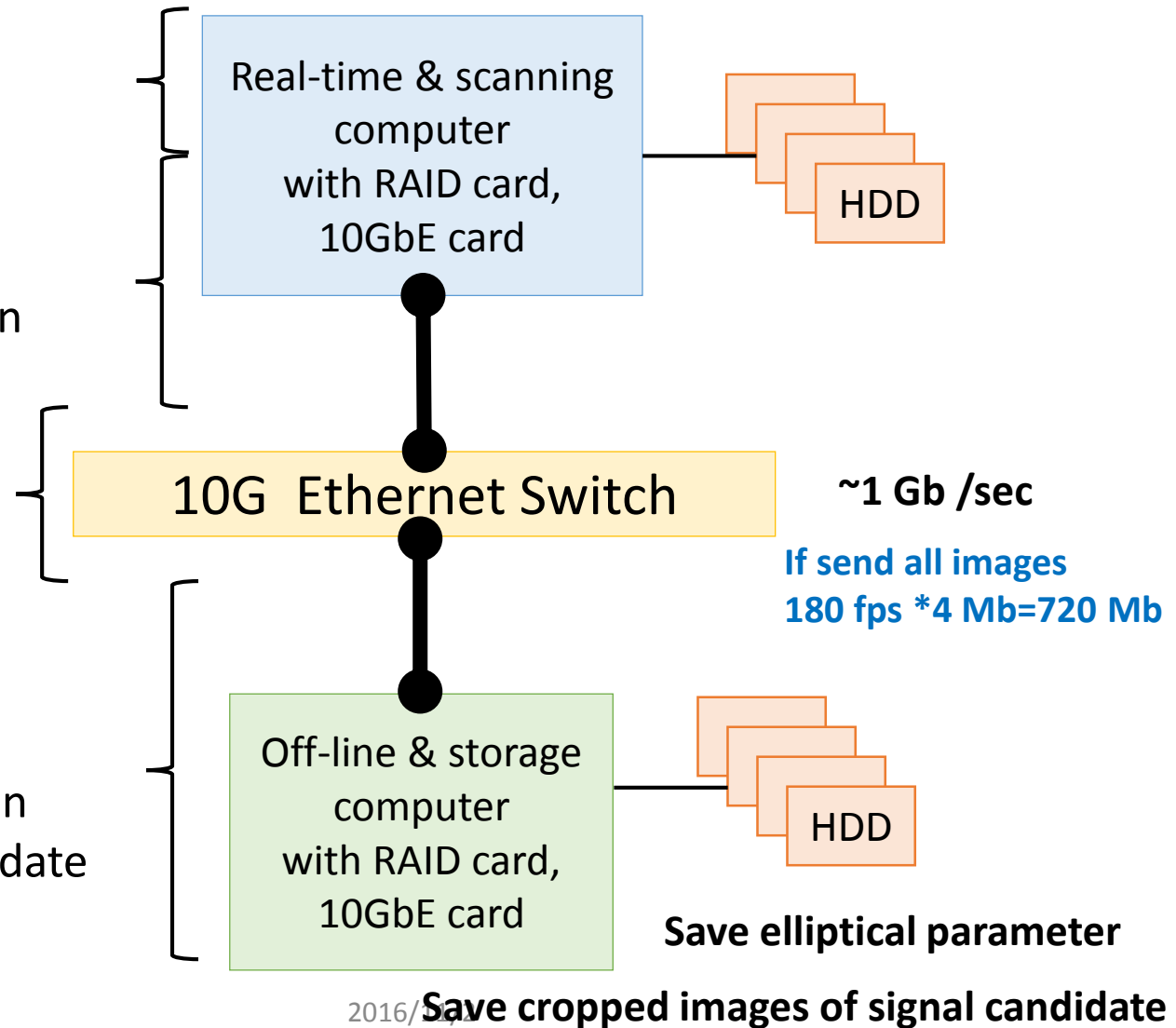
# Near future system of scanning system

Will separate tasks to 2 PC for parallel analyzing

- Stage control
- Camera control
- Image filter
- Surface recognition

**Send only fiducial images after surface recognition**

- Elliptical analysis
- Best focus selection
- Select signal candidate



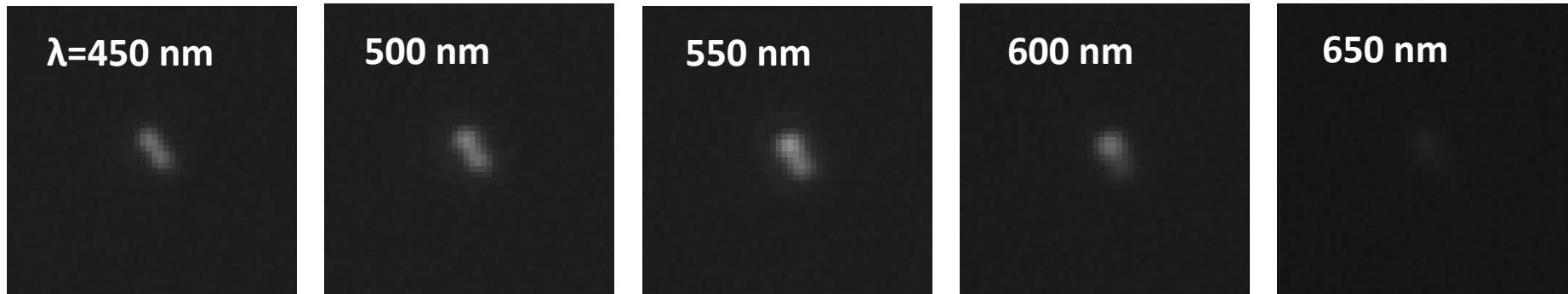
# Set up of Plasmon analysis

## Task

- scanning algorithm to see same event after 1<sup>st</sup> scan
  - high speed scanning
- 
- Polarization system in Napoli  
being constructed by Andrey
  - Multi wavelength analysis system in Japan  
bandpass filter is changed by my hand now  
⇒ think about automatic system

# Plasmon analysis about Dust

- Multi wavelength analysis has done about several events
- Sometime dust has optical change depended on the wavelength



**But maybe the value of shift of brightness is difference from the signal one  
⇒should be checked after meeting**

**e.g. parameter of Double Gaussian fitting of brightness distribution  
displacement of brightness point**

**Also combination multi wavelength and polarization effect is much strong**



# Conclusion

- Readout system the nanometric resolution and scanning speed
- Scanning strategy is :  
reject sphere noise and strange shape dust by Elliptical analysis  
at first, then select signal by using detail information by plasmon
- Readout system need to be improved for high scanning speed  
and high S/N ratio in JP and Italy